

ABSTRACT

To provide a method of fabricating a polyurethane foam with micro pores, and a polishing pad therefrom, the method including steps of (a) adding a nonionic surfactant into at least one of a first ingredient including an isocyanate group-containing compound and a second ingredient including an active hydrogen group-containing compound, (b) agitating and mixing the mixture of the first ingredient and the second ingredient while adding a non-reactive gas thereto, (c) discharging the mixture out of a container at a predetermined rate, and (d) injecting the discharged mixture into a mold so as to form a mold body into a predetermined shape.